

500.41295VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAWAGUCHI et al
Serial No.: (not yet assigned)
Filed: October 21, 2003
For: PLASMA PROCESSING METHOD AND APPARATUS
Group: 1765
Examiner: S. Ahmed

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 21, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Title and Specification;

Amendment to the Abstract;

Amendments to the Claims; and

Remarks are included following the amendments.